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| APPLICATION NO.                              | FILING DATE     | FIRST NAMED INVENTOR | ATTORNEY DOCKET NO.         | CONFIRMATION NO. |
|--|-----------------|----------------------|-----------------------------|------------------|
| 09/916,509                                   | 07/30/2001      | Katsuhiko Hieda      | 04329.2613 8843<br>EXAMINER |                  |
| 759  | 90 02/04/2005   |                      |                             |                  |
|  | derson, Farabow | LE, THAO X           |                             |                  |
| Garrett & Dunner, L.L.P. 1300 I Street, N.W. |                 |                      | ART UNIT                    | PAPER NUMBER     |
| Washington, DC 20005-3315                    |                 |                      | 2814                        |                  |
|  |                 |                      | DATE MAILED: 02/04/2005     |                  |

Please find below and/or attached an Office communication concerning this application or proceeding.

|   | Application No.  | Applicant(s)   |  |  |  |  |
|---|--|--|--|--|--|--|
| Office Action Commence  | 09/916,509   | HIEDA, KATSUHIKO   |  |  |  |  |
| Office Action Summary   | Examiner   | Art Unit   |  |  |  |  |
|   | Thao X. Le   | 2814   |  |  |  |  |
| The MAILING DATE of this communication ap<br>Period for Reply   | ppears on the cover sheet with the   | correspondence address   |  |  |  |  |
| A SHORTENED STATUTORY PERIOD FOR REPITHE MAILING DATE OF THIS COMMUNICATION  - Extensions of time may be available under the provisions of 37 CFR 1 after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above, is less than thirty (30) days, a recent of the period for reply is specified above, the maximum statutory, are Failure to reply within the set or extended period for reply will, by statu Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b). | .136(a). In no event, however, may a reply be t<br>ply within the statutory minimum of thirty (30) da<br>I will apply and will expire SIX (6) MONTHS fron<br>te, cause the application to become ABANDON         | imely filed  ys will be considered timely.  n the mailing date of this communication.  ED (35 U.S.C. § 133). |  |  |  |  |
| Status  |  |  |  |  |  |  |
| 1)⊠ Responsive to communication(s) filed on <u>07</u>   | October 2004.  |  |  |  |  |  |
|   | · · · · · · · · · · · · · · · · · · ·  |  |  |  |  |  |
| 3) Since this application is in condition for allow   | Since this application is in condition for allowance except for formal matters, prosecution as to the ments is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213. |  |  |  |  |  |
| Disposition of Claims   |  |  |  |  |  |  |
| 4) ⊠ Claim(s) 3-21,24-44 and 48 is/are pending in 4a) Of the above claim(s) 3-21 and 24-34 is/a 5) □ Claim(s) is/are allowed.  6) ⊠ Claim(s) 35-44,48 is/are rejected.  7) □ Claim(s) is/are objected to.  8) □ Claim(s) are subject to restriction and/  | re withdrawn from consideration.   |  |  |  |  |  |
| Application Papers  |  |  |  |  |  |  |
| 9) The specification is objected to by the Examin   |  |  |  |  |  |  |
| 10) ☐ The drawing(s) filed on 30 July 2001 is/are: a  |  | <u> </u>   |  |  |  |  |
| Applicant may not request that any objection to the   |  |  |  |  |  |  |
| Replacement drawing sheet(s) including the corre  | · · · · · · · · · · · · · · · · · · ·  |  |  |  |  |  |
| Priority under 35 U.S.C. § 119  |  |  |  |  |  |  |
| a) Acknowledgment is made of a claim for foreig a) All b) Some * c) None of:  1. Certified copies of the priority documer 2. Certified copies of the priority documer 3. Copies of the certified copies of the pri application from the International Burea * See the attached detailed Office action for a list  | nts have been received.<br>Its have been received in Applica<br>Onty documents have been receiv<br>au (PCT Rule 17.2(a)).  | tion No<br>ved in this National Stage  |  |  |  |  |
| Attachment(s)   |  |  |  |  |  |  |
| 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08 Paper No(s)/Mail Date   | 4) Interview Summar Paper No(s)/Mail [ 5) Notice of Informal 6) Other:   |  |  |  |  |  |

#### DETAILED ACTION

### Drawings

1. Figures 79-81 should be designated by a legend such as --Prior Art-- because only that which is old is illustrated. See MPEP § 608.02(g). Corrected drawings in compliance with 37 CFR 1.121(d) are required in reply to the Office action to avoid abandonment of the application. The replacement sheet(s) should be labeled "Replacement Sheet" in the page header (as per 37 CFR 1.121(d)) so as not to obstruct any portion of the drawing figures. If the changes are not accepted by the examiner, the applicant will be notified and informed of any required corrective action in the next Office action. The objection to the drawings will not be held in abeyance.

## Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 35-44 and 48 are rejected under 35 U.S.C. 103(a) as being unpatentable over US 5115289 to Hisamoto et al and in view of US 6316813 to Ohmi et al.

Regarding claims 1, Hisamoto discloses a semiconductor device comprising a convex semiconductor layer 100, column 7 line 17, fig 2a, provided on a semiconductor substrate 10, column 6 line 37, a source and a drain region 40/50, column 6 line 41, provided in the convex semiconductor layer 100, a semiconductor region 100, a gate insulator 91, fig. 1, column 6 line 50, on side surface of the convex semiconductor layer 100 and a top surface of the convex

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semiconductor layer, fig. 1, a gate electrode 30, column 6 line 38, on a portion of the gate insulator 91 between the source and drain regions 40/50, a trench capacitor 41, fig. 5 column 11 line 54, in the semiconductor substrate, fig. 5, the trench capacitor 41 connected to one of source and drain, fig. 5.

But Hisamoto does not expressly disclose the semiconductor substrate and convex semiconductor layer of a first conductivity and the S/D region of the second conductivity type.

However, Hisamoto discloses the transistor can be either N or P type channel, column 7 lines 4-5. In addition Ohmi explicitly discloses the transistor comprises the semiconductor substrate 2 and convex semiconductor layer 4 of a first conductivity (P) and the S/D region 6/7 of the second conductivity type (N). At the time the invention was made; it would have been obvious to one of ordinary skill in the art to use the semiconductor teaching of Ohmi with Hisamoto's device, because such semiconductor type is typical in the art to make either N type or P type channel FET.

Regarding claim 35, Hisamoto discloses a semiconductor device wherein a distance between the S/D 40/50 regions becomes longer toward a lower portion from the upper portion of the convex semiconductor layer 100, fig. 4e.

Regarding claim 36, Hisamoto does not disclose a semiconductor device wherein the impurity concentration of the S/D region 40/50 becomes lower toward a lower portion from an upper portion of the convex semiconductor layer.

However, Ohmi discloses a semiconductor device wherein the impurity concentration of the S/D region 40/50 becomes lower toward a lower portion from an upper portion of the convex semiconductor layer, fig. 8D. At the time the invention was

made; it would have been obvious to one of ordinary skill in the art to use the doping teaching of Ohmi with Hisamoto, because it would have created a LDD structure.

Regarding claim 37, Hisamoto discloses a semiconductor device wherein the sidewall gate portion 30 is formed to portion under the S/D region 40/50, fig. 1 along the side surface of the convex semiconductor layer 100, fig. 1.

Regarding claim 38, Hisamoto discloses a semiconductor device wherein a width of the convex semiconductor layer is smaller than 0.2 µm, column 7 lines 35-55.

Regarding claim 39, Hisamoto discloses a semiconductor device wherein a width of the convex semiconductor layer 100 is smaller than the depth of the S/D region 40/50, fig. 1.

Regarding claims 40-42, Hisamoto discloses a semiconductor device wherein at least one of the S/D regions 40/50 and the convex semiconductor 100 is electrically connected to the conductive substrate, fig 5.

But Hisamoto does not disclose a semiconductor device wherein at least one of the S/D regions includes at least two kinds of diffusion layers, a high and low concentration, having a dense impurity concentration diffusion layer.

However, Ohmi discloses a semiconductor device wherein at least one of the S/D regions 40/50 includes at least two kinds of diffusion layers 6 and 37, a high and low concentration N<sup>+</sup> and N<sup>-</sup>, having a dense impurity concentration diffusion layer, and the convex semiconductor is electrically connected to the conductive substrate, fig 8D. At the time the invention was made; it would have been obvious to one of ordinary skill in the art to use the doping teaching of Ohmi with Hisamoto, because it would have created a LDD structure.

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Regarding claims 44, Hisamoto discloses a semiconductor device wherein a position of a deepest portion of the gate electrode is deeper that a position of the deepest portion of the S/D region, fig. 1.

4. Claims 43 is rejected under 35 U.S.C. 103(a) as being unpatentable over US 5115289 to Hisamoto et al and US 6316813 to Ohmi et al as applied to claim 48 above and further in view in view of US 6333229 to Furukawa et al.

Regarding claims 43, Hisamoto discloses a semiconductor device comprising a gate insulating film 91 is made of a silicon oxide, column 8, line 30.

But Hisamoto does not disclose the gate oxide comprises the oxide including at least one of Ta, Ti.

However, Furukawa reference disclose the gate oxide layer 30 comprise silicon oxide, titanium oxide, and tantalum oxide, column 3 lines 48-52. At the time of the invention was made; it would have been obvious to one of ordinary skill in the art to replace the gate silicon oxide of Ohmi with titanium or tantalum oxide gate oxide teaching of Furukawa, because such material substitution would have been considered a mere substitution of art-recognized equivalent material.

### Response to Arguments

5. Applicant's arguments with respect to claims 35-44 and 48 have been considered but are moot in view of the new ground(s) of rejection.

### Conclusion

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6. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

7. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thao X. Le whose telephone number is (571) 272-1708. The examiner can normally be reached on M-F from 8:00 AM - 4:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Wael M. Fahmy can be reached on (571) 272 -1705. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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Thao X. Le 28 Jan 2004

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